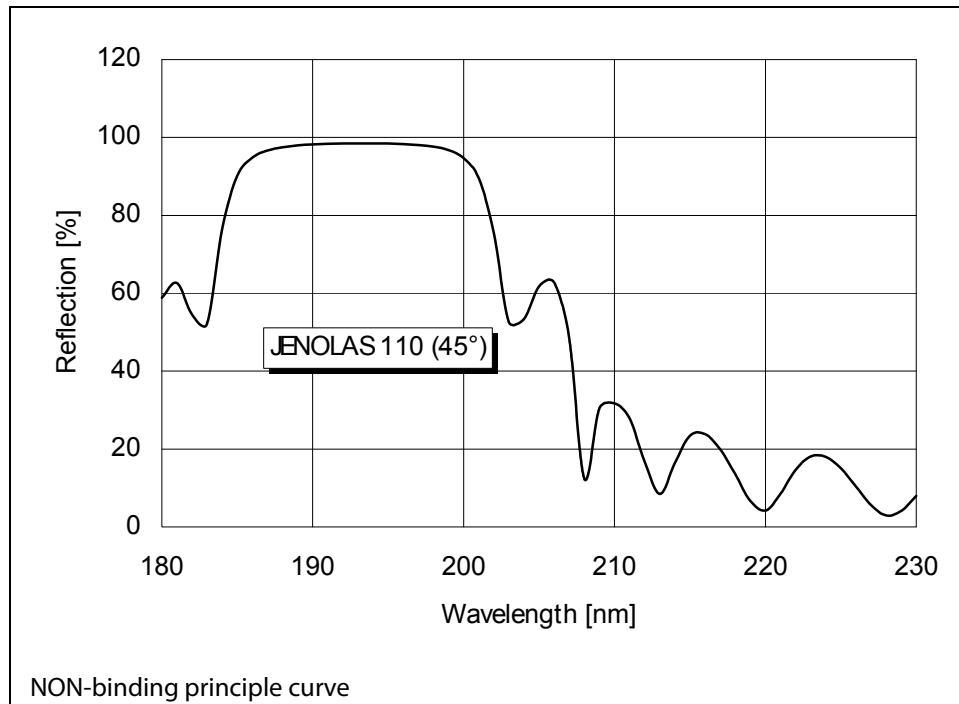


JENOLAS 110

Laser Mirror for ArF-Excimerlaser (193 nm)



Laser Mirror
for VUV Laser

Optical properties:

R \geq 96 % for 193 nm

Applications:

Multilayer high-reflective coating
for enhanced Laser Damage Threshold (193 nm)

Angle of Incidence: typical 0° ... 45°

Durability:

Adhesion: MIL-C-48497A / section 4.5.3.1

Special care should be taken for better durability.

Substrate material:

The coating is specified for Applications only on
Fluoride-Substrates.

Issue:

September 00

Doc-No.:

Ordering code:

JENOLAS 110 (angle of incidence)